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JUL 6 2004

In re Application of
Katsura Miyashita et al.
Application No.: 09/916,530
Filed: July 30, 2001

WITHDRAWAL FROM ISSUE
37 C.F.R. § 1.313

For: SEMICONDUCTOR DEVICE COMPRISING METAL
SILICIDE FILMS FORMED TO COVER GATE
ELECTRODE AND SOURCE-DRAIN DIFFUSION
LAYERS AND METHOD OF MANUFACTURING THE
SAME

The above-identified application is withdrawn from issue after payment of the issue fee due to unpatentability of one or more claims. See 37 C.F.R. § 1.313(b)(3).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Fee(s) Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance and Fee(s) Due in order to prevent abandonment of the application.

Telephone inquiries should be directed John Niebling, Supervisory Patent Examiner, at (571) 272-1679.

The examiner will notify applicant of the new status of this application in an Office action to be issued promptly.

Sharon Gibson, Group Director
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Semiconductors, Electrical and Optical
Systems and Components